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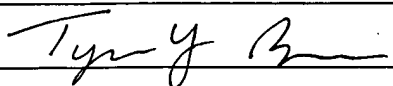
(to be used for all correspondence after initial filing)

		Application Number	10/644,644
		Filing Date	August 19, 2003
		First Named Inventor	Henley, Francois J.
		Art Unit	Unassigned
		Examiner Name	Unassigned
Total Number of Pages in This Submission	16	Attorney Docket Number	018419-000183US

ENCLOSURES (Check all that apply)

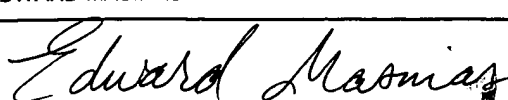
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement (2 pgs) w/attached PTO/SB/08A (9 pgs), citing references 1-254, and PTO/SB/08B (3 pages) citing references 255-287) <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): Return Postcard
Remarks: The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.		

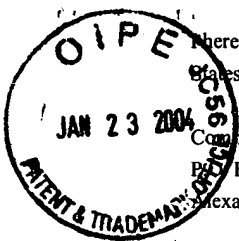
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual	Townsend and Townsend and Crew LLP	
	Tyrome Y. Brown	Reg. No. 46,580
Signature		
Date	January 14, 2004	

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.

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PATENT
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On

1-20-04

TOWNSEND and TOWNSEND and CREW LLP

By:

Edward Masinas

Edward Masinas

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Francois J. Henley et al.

Application No.: 10/644,644

Filed: August 19, 2003

For: CONTROLLED CLEAVING
PROCESS

Examiner: Not Yet Assigned

Art Unit: Not Yet Assigned

INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. In accordance with 37 CFR §1.98(d), copies of the references can be found in Application No. 09/483,393, now U.S Patent 6,632,724 B2, issued October 14, 2003 (Attorney Docket No. 018419-000182US). It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Tyrome Y. Brown
Reg. No. 46,580

TOWNSEND and TOWNSEND and CREW LLP
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60070501 v1



Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
Application Number				10/644,644	
Filing Date				August 19, 2003	
First Named Inventor				Henley, Francois J.	
Art Unit				Not Yet Assigned	
Examiner Name				Not Yet Assigned	
Attorney Docket Number				018419-000183US	
Sheet	1	of	12		

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code ² (if known)			
	1	2,614,055	10/1952	Senarelens	
	2	3,117,022	01/1964	Bronson et al.	
	3	3,225,820	12/1995	Riordan	
	4	3,390,033	06/1968	Brown	
	5	3,551,213	12/1970	Boyle	
	6	3,770,499	10/1973	Crowe et al.	
	7	3,786,359	01/1974	King	
	8	3,806,380	04/1974	Kitada et al.	
	9	3,832,219	08/1974	Nelson et al.	
	10	3,900,636	08/1975	Curry et al.	
	11	3,901,423	08/1975	Hillberry et al.	
	12	3,915,757	10/1975	Engel	
	13	3,946,334	03/1976	Yonezu et al.	
	14	3,957,107	05/1976	Altoz et al.	
	15	3,993,909	11/1976	Drews et al.	
	16	4,006,340	02/1977	Gorinas	
	17	4,039,416	08/1977	White	
	18	4,053,335	10/1977	Hu	
	19	4,074,139	02/1978	Pankove	
	20	4,107,350	08/1978	Berg et al.	
	21	4,108,751	08/1978	King	
	22	4,116,751	09/1978	Zaromb	
	23	4,121,334	10/1978	Wallis	
	24	4,170,662	10/1979	Weiss et al.	
	25	4,216,906	08/1980	Olsen et al.	
	26	4,237,601	12/1980	Woolhouse et al.	
	27	4,244,348	01/1981	Wilkes	
	28	4,252,837	02/1981	Auton	
	29	4,255,208	03/1981	Deutscher et al.	
Examiner Signature				Date Considered	

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				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
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U.S. PATENT DOCUMENTS+					
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		Number Kind Code ² (if known)			
	30	4,274,004	06/1981	Kanai	
	31	4,342,631	08/1982	White et al.	
	32	4,346,123	08/1982	Kaufmann	
	33	4,361,600	11/1982	Brown	
	34	4,368,083	01/1983	Bruel et al.	
	35	4,375,125	03/1983	Byatt	
	36	4,412,868	11/1983	Brown et al.	
	37	4,452,644	06/1984	Bruel et al.	
	38	4,468,309	08/1984	White	
	39	4,471,003	09/1984	Cann	
	40	4,486,247	12/1984	Ecer et al.	
	41	4,490,190	12/1984	Speri	
	42	4,500,563	02/1985	Ellenberger et al.	
	43	4,508,056	04/1985	Bruel et al.	
	44	4,536,657	08/1985	Bruel	
	45	4,539,050	09/1985	Kramler et al.	
	46	4,566,403	01/1986	Fournier	
	47	4,567,505	01/1986	Pease et al.	
	48	4,568,563	02/1986	Jackson et al.	
	49	4,585,945	04/1986	Bruel et al.	
	50	4,645,546	02/1987	Matsushita	
	51	4,684,535	08/1987	Heinecke et al.	
	52	4,704,302	11/1987	Bruel et al.	
	53	4,706,377	11/1987	Shuskus	
	54	4,717,683	01/1988	Parrillo et al.	
	55	4,727,047	02/1988	Bozler et al.	
	56	4,764,394	08/1988	Conrad	
	57	4,766,086	08/1988	Ohshima et al.	
	58	4,837,172	06/1989	Mizuno et al.	

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60070501 v1



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					First Named Inventor	Henley, Francois J.
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	59	4,846,928	07/1989	Dolins et al.	
	60	4,847,792	07/1989	Barna et al.	
	61	4,853,250	08/1989	Boulos et al.	
	62	4,883,561	11//1989	Gmitter et al.	
	63	4,887,005	12/1989	Rough et al.	
	64	4,891,329	01/1990	Reisman et al.	
	65	4,894,709	01/1990	Phillips et al.	
	66	4,931,405	06/1990	Kamijo et al.	
	67	4,948,458	08/1990	Ogle	
	68	4,952,273	08/1990	Popov	
	69	4,956,693	09/1990	Sawahata et al.	
	70	4,960,073	10/1990	Suzuki et al.	
	71	4,982,090	01/1991	Wittmaack	
	72	4,983,251	01/1991	Haisma et al.	
	73	4,996,077	02/1991	Moslehi et al.	
	74	5,015,353	05/1991	Hubler et al.	
	75	5,034,343	07/1991	Rouse et al.	
	76	5,070,040	12/1991	Pankove	
	77	5,082,793	01/1992	Li	
	78	5,102,821	04/1992	Moslehi	
	79	5,110,748	05/1992	Sarma	
	80	5,133,826	07/1992	Dandl	
	81	5,162,241	11/1992	Mori et al.	
	82	5,196,355	03/1993	Wittkower	
	83	5,198,371	03/1993	Li	
	84	5,202,095	04/1993	Houchin et al.	
	85	5,203,960	04/1993	Dandl	
	86	5,206,749	04/1993	Zavracky et al.	
	87	5,213,451	05/1993	Frank	

Examiner Signature		Date Considered	
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60070501 v1



Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

4

of

12

Complete if Known

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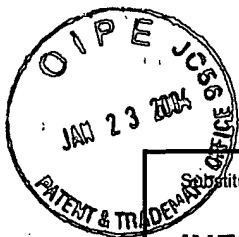
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		Number Kind Code ² (if known)			
	88	5,234,529	08/1993	Johnson	
	89	5,234,535	08/1993	Beyer et al.	
	90	5,242,861	09/1993	Inaba	
	91	5,250,328	10/1993	Otto	
	92	5,252,178	10/1993	Moslehi	
	93	5,256,562	10/1993	Vu et al.	
	94	5,258,320	11/1993	Zavracky et al.	
	95	5,258,325	11/1993	Spitzer et al.	
	96	5,269,880	12/1993	Jolly et al.	
	97	5,273,610	12/1993	Thomas, III et al.	
	98	5,277,748	01/1994	Sakaguchi et al.	
	99	5,303,574	04/1994	Matossian et al.	
	100	5,304,509	04/1994	Sopori	
	101	5,308,776	05/1994	Gotou	
	102	5,317,236	05/1994	Zavracky et al.	
	103	5,342,472	08/1994	Imahashi et al.	
	104	5,344,524	09/1994	Sharma et al.	
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	106	5,362,671	11/1994	Zavracky et al.	
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	108	5,368,710	11/1994	Chen et al.	
	109	5,370,765	12/1994	Dandl	
	110	5,374,564	12/1994	Bruel	
	111	5,376,560	12/1994	Aronowitz et al.	
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	115	5,411,592	05/1995	Ovshinsky et al.	
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U.S. PATENT DOCUMENTS+					
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		Number Kind Code ² (if known)			
	117	5,435,880	07/1995	Minato et al.	
	118	5,438,241	08/1995	Zavracky et al.	
	119	5,443,661	08/1995	Oguro et al.	
	120	5,444,557	08/1995	Spitzer et al.	
	121	5,459,016	10/1995	Debe et al.	
	122	5,475,514	12/1995	Salerno et al.	
	123	5,476,691	12/1995	Komvopoulos et al.	
	124	5,480,842	01/1996	Clifton et al.	
	125	5,487,785	01/1996	Horiike et al.	
	126	5,494,835	02/1996	Bruel	
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	128	5,528,397	06/1996	Zavracky et al.	
	129	5,539,245	06/1996	Imura et al.	
	130	5,558,718	09/1996	Leung	
	131	5,559,043	09/1996	Bruel	
	132	5,569,620	10/1996	Linn et al.	
	133	5,581,385	12/1996	Spitzer et al.	
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	140	5,714,395	02/1998	Bruel	
	141	5,744,852	04/1998	Linn et al.	
	142	5,753,560	05/1998	Hong et al.	
	143	5,755,914	05/1998	Yonehara	
	144	5,763,319	06/1998	Ling et al.	
	145	5,783,022	07/1998	Cha et al.	

Examiner Signature		Date Considered	
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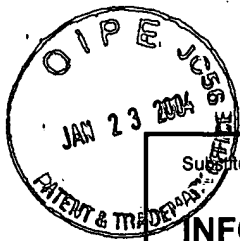


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	146	5,804,086	09/1998	Bruel	
	147	5,821,158	10/1998	Shishiguchi	
	148	5,824,595	10/1998	Igel et al.	
	149	5,827,751	10/1998	Nuyen	
	150	5,840,590	11/1998	Myers, Jr. et al.	
	151	5,854,123	12/1998	Sato et al.	
	152	5,869,387	02/1999	Sato et al.	
	153	5,877,070	03/1999	Goesele et al.	
	154	5,882,987	03/1999	Srikrishnan	
	155	5,909,627	06/1999	Egloff	
	156	5,920,764	07/1999	Hanson et al.	
	157	5,953,622	09/1999	Lee et al.	
	158	5,966,620	10/1999	Sakaguchi et al.	
	159	5,985,742	11/1999	Henley et al.	
	160	5,993,677	11/1999	Biasse et al.	
	161	5,994,207	11/1999	Henley et al.	
	162	6,010,579	01/2000	Henley et al.	
	163	6,013,563	01/2000	Henley et al.	
	164	6,020,252	02/2000	Aspar et al.	
	165	6,033,974	03/2000	Henley et al.	
	166	6,048,411	04/2000	Henley et al.	
	167	6,077,383	06/2000	Laporte	
	168	6,083,324	07/2000	Henley	
	169	6,120,597	09/2000	Levy et al.	
	170	6,150,239	11/2000	Goesele et al.	
	171	6,159,824	12/2000	Henley et al.	
	172	6,171,965	01/2001	Kang et al.	
	173	6,184,111	02/2001	Henley et al.	

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	174	6,190,998	02/2001	Bruel et al.	
	175	6,191,007	02/2001	Matsui et al.	
	176	6,214,701	04/2001	Matsushita et al.	
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Substitute for form 1449A/PTO				Complete if Known	
				Application Number	10/644,644
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Filing Date	August 19, 2003
				First Named Inventor	Henley, Francois J.
				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	018419-000183US
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STATEMENT BY APPLICANT**

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Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	018419-000183US

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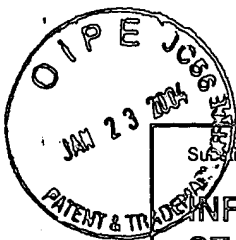
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
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<div>Substitute for form 1449B/PTO</div> <div>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</div> <div>(use as many sheets as necessary)</div>				C mplete if Known	
				Application Number	10/644,644
				Filing Date	August 19, 2003
				First Named Inventor	Henley, Francois J.
				Art Unit	Not Yet Assigned
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Sheet	11	of	12	Attorney Docket Number	018419-000183US

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				Art Unit	Not Yet Assigned
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